

## APPLICATION DATA SHEET

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Application Information: Title: METHOD AND STRUCTURE FOR PROTECTING  
 NROM DEVICES FROM INDUCED CHARGE  
 DAMAGE DURING DEVICE FABRICATION

Classification: Class: Subclass:  
 Tech Center:  
 Drawing Sheets: 2 Drawing to be Published:  
 Docket No: H1369  
 Type: Utility  
 Secrecy: None

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## Domestic Priority:

Application:	Continuity Type:	Parent Application:	Parent Filing Date:
None			

## Foreign Priority Information

Country:	Application Number:	Filing Date:	Priority Claimed:
None			

Assignee:     Advanced Micro Devices, Inc.  
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